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Dated: 4/14/03

Signature:

Anna P. Lucey
(Anna P. Lucey)

Docket No.: BVTP-P04-506
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Allen et al.

Application No.: 10/010723

Group Art Unit: 3763

Filed: December 6, 2001

Examiner: Thompson, Kathryn L.

For: MICRONEEDLE DEVICES AND METHODS
OF MANUFACTURE AND USE THEREOF

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents
Washington, DC 20231

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed more than three months after the U.S. filing date, OR more than three months after the date of entry of the national stage of a PCT application, AND after the mailing date of the first Office Action on the merits, whichever occurs first, but before the mailing date of a Final Rejection or Notice of Allowance.

This is Part Two of a two-part Information Disclosure Statement. Part One, citing U.S. Patent art, was filed electronically on the above signed date. The fee of \$180.00 set forth under 37 C.F.R. 1.17(p) was paid online with Part One.

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Those patent(s) or publication(s) which are not marked with an asterisk (*) on the attached Form PTO/SB/08 are not supplied because they were previously cited by or submitted to the Office in prior application no. 09/316,229 filed 05/21/1999, now PAT 6,334,856 which is relied upon in this application for an earlier filing date under 35 U.S.C. 120.

While the information and references disclosed in this Information Disclosure Statement may be "material" pursuant to 37 CFR 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents should one or more of the documents be applied against the claims of the present application.

The Commissioner is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 18-1945, under Order No. BVTP-P04-506.

Dated:

4/14/03

Respectfully submitted,

By Agnes S. Lee

Agnes S. Lee
Registration No.: 46,862
ROPES & GRAY
One International Place
Boston, Massachusetts 02110-2624
(617) 951-7000
(617) 951-7050 (Fax)
Attorneys/Agents For Applicant



PTO/SB/08A (10-01)

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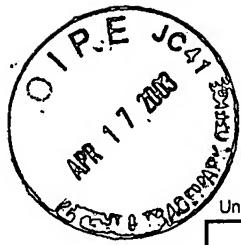
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Substitute for form 1449A/PTO				Complete if Known	
				Application Number	10/010723
				Filing Date	December 6, 2001
				First Named Inventor	Mark G. Allen
				Art Unit	3763
				Examiner Name	Thompson, Kathryn L.
Sheet	1	of	4	Attorney Docket Number	BVTP-P04-506

U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)	MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
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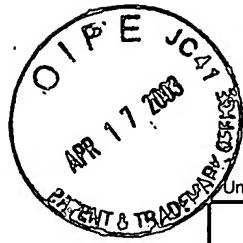
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Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	MM-DD-YYYY		T ⁶
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*CC		WO 00/48669	08/24/2000	Biovalve Technologies	
*CD		WO 00/74763	12/14/2000	Georgia Tech Research	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See attached Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

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of

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Complete if Known	
Application Number	10/010723
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Art Unit	3763
Examiner Name	Thompson, Kathryn L.
Attorney Docket Number	BVTP-P04-506

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*CL	Eleventh Annual International Workshop on Micro Electro Mechanical Systems, Heidelberg, Germany (25-29 Jan. 1998). IEEE Catalog No. 98CH36176
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CS	Hoffert, S.P. Transcutaneous Methods Get Under the Skin. The Scientist 12, no. 16 (17 Aug. 1998).
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CU	Jaeger, R.C. <u>Introduction to Microelectronic Fabrication</u> in the Addison-Wesley Modular Series on Solid State Devices, G.W. Neudeck and R.F. Pierret, eds. Vol. 5, Addison-Wesley Publishing Co., Inc. (May 1993).
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Attorney Docket Number BVTP-P04-506

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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